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|--|--|--------------------------|-----------------------------|-------|------------------------|-------------------|
| AMENDMENT TRANSMITTAL LETTER (Large Entity) Applicant(s): Naoki KIDANI et al | | | | | Docket No. TPP 31769 | |
| Application No. 10/540,014 | Filing Date June 22, 2005 | Examiner K. Group | Customer N 24257 | No. (| Group Art Unit 1755 | Confirmation No. |
| LOW TEMPERATURE SINTERING CERAMIC COMPOSITION FOR USE IN HIGH FREQUENCY, METHOD OF FABRICATING THE SAME AND ELECTRONIC COMPONENT | | | | | | |
| COMMISSIONER FOR PATENTS: Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below. | | | | | | |
| CLAIMS AS AMENDED | | | | | | |
| | CLAIMS REMAINING AFTER AMENDMENT | HIGHEST # PREV. PAID FOR | NUMBER EXTRA CLAIMS PRESENT | | RATE | ADDITIONAL FEE |
| TOTAL CLAIMS | 8 - | 20 = | 0 | х | \$50.00 | \$0.00 |
| NDEP. CLAIMS | 2 - | 3 = | 0 | x | \$200.00 | \$0.00 |
| Multiple Dependent Claims (check if applicable) | | | | | | |
| TOTAL ADDITIONAL FEE FOR THIS AMENDMENT \$0.00 | | | | | | |
| No additional fee is required for amendment. □ Please charge Deposit Account No. in the amount of □ A check in the amount of to cover the filing fee is enclosed. ☑ The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 19-4375 ☑ Any additional filing fees required under 37 C.F.R. 1.16. □ Any patent application processing fees under 37 CFR 1.17. □ Payment by credit card. Form PTO-2038. WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038. | | | | | | |
| Thomas P. Pavelk Registration No. 3 STEVENS, DAVI 1615 L Street, N.V Washington, D.C. Telephone: (202) Facsimile: (202) | I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on (Date) Signature of Person Mailing Correspondence | | | | | |
| cc: | _ | | | | | |

Typed or Printed Name of Person Mailing Correspondence

In re the Application of

Confirmation No.: 2648

Naoki KIDANI et al

Group Art Unit: 1755

Serial No.: 10/540,014

Examiner: K. Group

Filed: June 22, 2005

For:

LOW TEMPERATURE SINTERING CERAMIC COMPOSITION FOR USE IN HIGH

FREQUENCY, METHOD OF FABRICATING THE SAME AND ELECTRONIC COMPONENT

AMENDMENT AFTER FINAL REJECTION

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Dear Sir:

Responsive to the Office Action mailed April 4, 2007, please amend the above-identified application as follows.